

Electronic Filing System (EFS) Data Electronic Patent Application Submission USPTO Use Only 10-046497

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Application ID:

Title of Invention:

10046497_

Method for Forming Raised

Structures by Controlled Selective

Epitaxial Growth of Facet Using

Information Disclosure Statement

Spacer

First Named Inventor:

Er-Xuan Ping

Domestic/Foreign Application:

Domestic Application

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2002-10-03

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8624

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Attorney Docket Number:

MTI-31041-A

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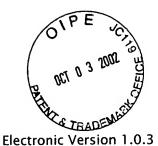
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Page 1 of 1



TRANSMITTAL FORM

Application

Number:

10/046,497

Attorney Docket

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Stylesheet Version: 1.0

Submission Type: Information

Disclosure Statement

Method for Forming Raised Structures by Controlled Selective Epitaxial Growth of Facet Using Spacer

First Named Inventor: Er-Xuan Ping

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atent applicants or their fficial correspondence by

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Attached Files:

us-information-disclosure-statement

MTI31041Aids.xml

Comments:

APP_ID=10046497 Page 2 of 2

Electronic Information Disclosure **Statement**

Method for Forming Raised Structures by Controlled Selective Epitaxial Growth of Facet Using Space Sp

Application:

Confirmation:

8624

Applicant(s):

Er-Xuan Ping

Docket

MTI-31041-A

Number:

Group Art Unit: 2814

Examiner:

search string:

(5393681 or 6391692 or 5308782 or 5998248 or 6319782 or 4554570 or 5200352 or 5376562 or

5079180 or 5753555).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

llinit	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
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Signature

Examiner Name	Date		
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